

Electronic Acknowledgement Receipt

EFS ID:	1436352
Application Number:	10623581
International Application Number:	
Confirmation Number:	6534
Title of Invention:	METHOD OF MANUFACTURING A SEMICONDUCTOR METHOD OF MANUFACTURING A THIN-FILM TRANSISTOR AND THIN-FILM TRANSISTOR
First Named Inventor/Applicant Name:	Isamu Kobori
Customer Number:	26171
Filer:	John F. Hayden/Andrea Turner
Filer Authorized By:	John F. Hayden
Attorney Docket Number:	07977-024003
Receipt Date:	12-JAN-2007
Filing Date:	22-JUL-2003
Time Stamp:	15:54:07
Application Type:	Utility

Payment information:

Submitted with Payment	no
------------------------	----

File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)
1	Information Disclosure Statement (IDS) Filed	07977-024003-IDS.pdf	67034	no	2

Warnings:

Information:

This is not an USPTO supplied IDS fillable form

Total Files Size (in bytes):

67034

This Acknowledgement Receipt evidences receipt on the noted date by the USPTO of the indicated documents, characterized by the applicant, and including page counts, where applicable. It serves as evidence of receipt similar to a Post Card, as described in MPEP 503.

New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.